PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Group Art Unit: 1762

Makoto NAKADATE

Application No.: 10/782,947

Examiner: M. B. CLEVELAND

Filed: February 23, 2004

Docket No.: 118824

For: MASK, METHOD OF MANUFACTURING MASK, DEVICE FOR MANUFACTURING MASK, METHOD OF MANUFACTURING LAYER OF LUMINESCENT MATERIAL, ELECTRO-OPTICAL DEVICE, AND ELECTRONIC DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

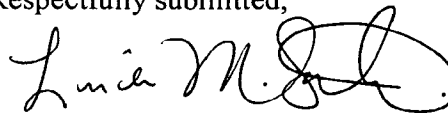
Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. One or more reference cited herein was cited in a counterpart foreign application. An English language version of the foreign Office Action is attached for the Examiner's information. See Reference 1.
- ☒ 3. An English language Abstract of one or more non-English language reference is attached hereto. See Reference 1.
- ☒ 4. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See Reference 1.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /BT/

- ☒ 5. Reference JP A 2001-237073, cited in the foreign Office Action, was previously submitted in an Information Disclosure Statement on February 23, 2004. Therefore, it is not attached hereto.

Respectfully submitted,



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Date: March 7, 2006

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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Sheet 1 of 1

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 118824		APPLICATION NO. 10/782,947	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Makoto NAKADATE			
				FILING DATE February 23, 2004			
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	1.	JP A 2000-12613	1/14/2000	Japan	X	X	
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
EXAMINER		/Binh Tran/			DATE CONSIDERED 11/05/2008		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: March 7, 2006

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /BT/